

SEARCHED

| Class | Sub. | Date | Exmr. |
|-------|------|-----------|-------|
| 638 | 706 | 12/13/100 | LV |
| | 710 | | |
| | 712 | | |
| | 720 | | |
| | 14 | | |
| | 57 | | |
| | 58 | | |
| | 59 | 1/13/100 | LV |

Dry
shaking

Manner
biting

Gas
phase
sticking

SEARCH NOTES (INCLUDING SEARCH STRATEGY)

| | Date | Exmr. |
|-------------------------|-----------|-------|
| ONS text search | 11/13/100 | LV |
| Using Fast | | |
| Consultal with | 12/13/100 | LV |
| Benjamin Welch | | |
| regarding of the | | |
| 602 rejection of | | |
| Claim 8 specifically | | |
| about how determining | | |
| an etch endpoint | | |
| based on a voltage | | |
| drop across a resistor | | |
| as taught in Winneke, | | |
| reads on changing | | |
| etching parameters when | | |
| the voltage across | | |
| a resistor drops | | |

INTERFERENCE SEARCHED

| Class | Sub. | Date | Exmr. |
|-------|------|------|-------|
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